



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

Masaaki KURIHARA et al.

Group Art Unit: 1756

Application No.: 10/614,345

Examiner: J. RUGGLES

Filed: July 8, 2003

Docket No.: 123770

For: PHASE MASK FOR FORMING
DIFFRACTION GRATING, METHOD OF
FABRICATING PHASE MASK AND
METHOD OF FORMING DIFFRACTION
GRATING

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

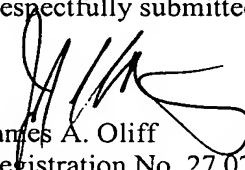
In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)
continued examination.

☒ Applicant(s) further request(s) entry and consideration of the Amendment After Final
Rejection submission filed September 14, 2006.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 185510 in the amount of ☒ \$790.00 as payment of the fees
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two
duplicate copies of this page are enclosed.

Respectfully submitted,


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JAO:JSA/lbg

Date: October 24, 2006

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